Attorney Docket No.:05225.0168

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	, a
Takashi YOSHIKAWA	7.714
Serial No.: Not yet assigned	Group Art Unit: Not assigned
Filed: September 22, 2000	Examiner: Not assigned
For: A CENTRAL PROCESSING APPAR	RATUS AND A COMPILE METHOD
Assistant Commissioner for Patents	

Sir:

Washington, DC 20231

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), applicant brings to the Examiner's attention the documents listed on attached Form PTO-1449. Copies of the listed documents are attached. Applicant respectfully request that the Examiner consider the documents listed on attached Form PTO-1449 and indicate that they were considered by making an appropriate notation on this form.

This Information Disclosure Statement is being filed with the abovereferenced application.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and applicant determine that the cited documents do not constitute "prior art" under United States law, applicant reserves the right to present to the office the relevant facts and law regarding the appropriate status of such documents.

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Applicant further reserves the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

By:

Richard V. Burgujian

Reg. No. 31,744

Dated: September 22, 2000

Enclosures RVB/FPD/dvz